

Development of X-ray phase imaging method using a compact high-brightness X-ray generator  
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# Development of X-ray phase imaging method using a compact high-brightness X-ray generator

Sub-theme: Evaluation of the Gratings for a Talbot-Lau Interferometer

Tohoku University, IMRAM

Margie P. Olbinado, Atsushi Momose

# Purpose of this work

To determine the **optimum X-ray energy** for the grating interferometer by measuring the X-ray energy at which there is **maximum fringe visibility**

To be able to give a recommendation for the X-ray source energy setting for X-ray phase imaging using this grating interferometer

# Background

The optimum energy is for which the phase grating gives  $\frac{\pi}{2}$  X-ray phase shift:

$$\phi(E) = \frac{2\pi}{\lambda} \delta(E) h_1$$

↑  
optimum energy

□ Grating parameters for a Talbot-Lau interferometer  **$E = 30$  keV** was designed and acquired

Grating Type	Source Grating, G0	Phase Grating, G1 $\pi/2$ phase shift at 30 keV	Analyzer Grating, G2
Material	Au	Ni	Au
Period ( $\mu\text{m}$ )	6.82	3.57	7.49
Structure Height ( $\mu\text{m}$ )	Design: 70 Measured: >70 +-10%	Design: 5.23 Measured: 5.34 +- 0.35	Design: 100 Measured: 103

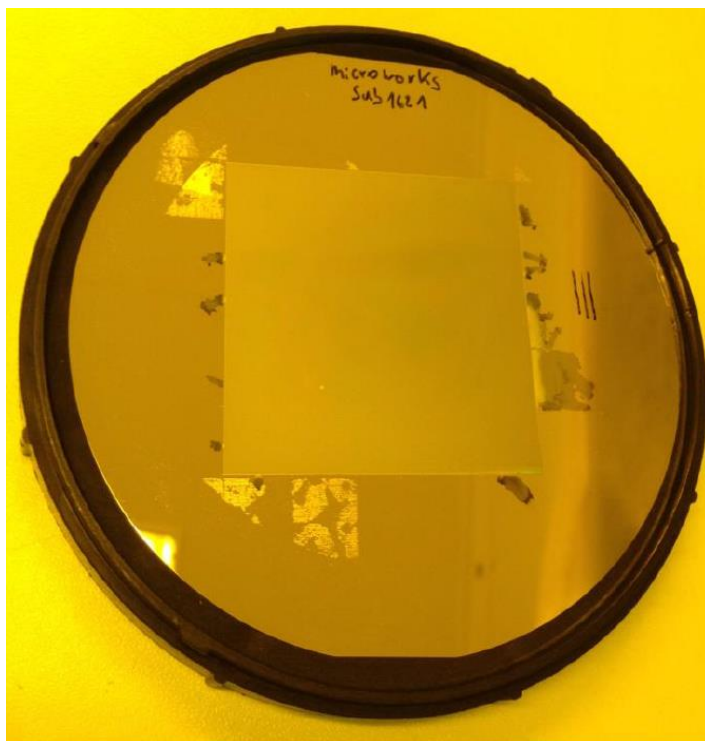
The maximum moiré fringe visibility was observed at 26 keV. An incorrect grating height was suspected and a replacement grating was requested from Microworks (Germany).

# Replacement Phase Grating

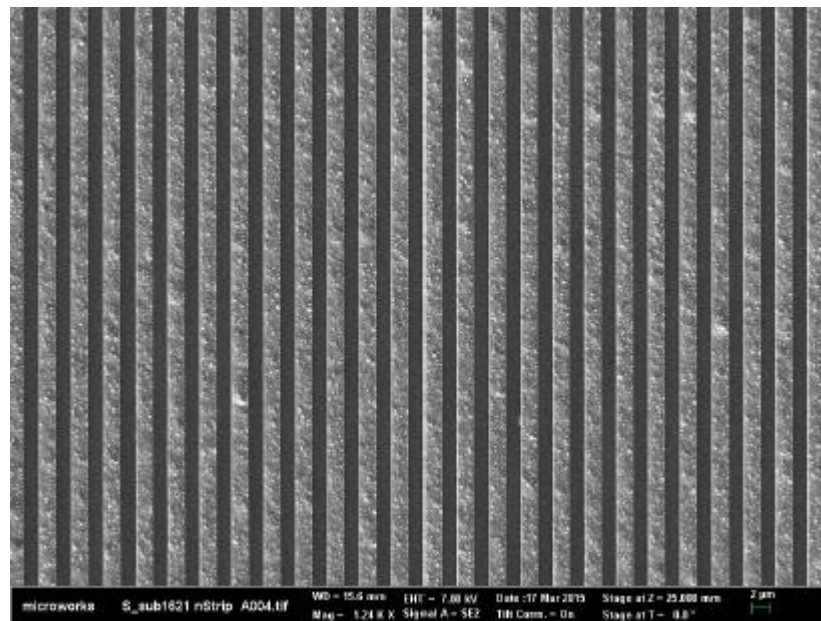
## Specifications:

Grating period	3,57 $\mu\text{m}$
Grating height specified	Nickel height 5.23 $\mu\text{m}$
Mask for exposure	1266_00_A0 Los Nr. 05285
Substrate type	200 $\mu\text{m}$ Si, CrAu seed layer

Actual parameters of the grating:	
Grating quality	Good
Ni height	5,18 +/- 0.27 $\mu\text{m}$
Grating DC	0,51 +/- 0,03



SEM Image



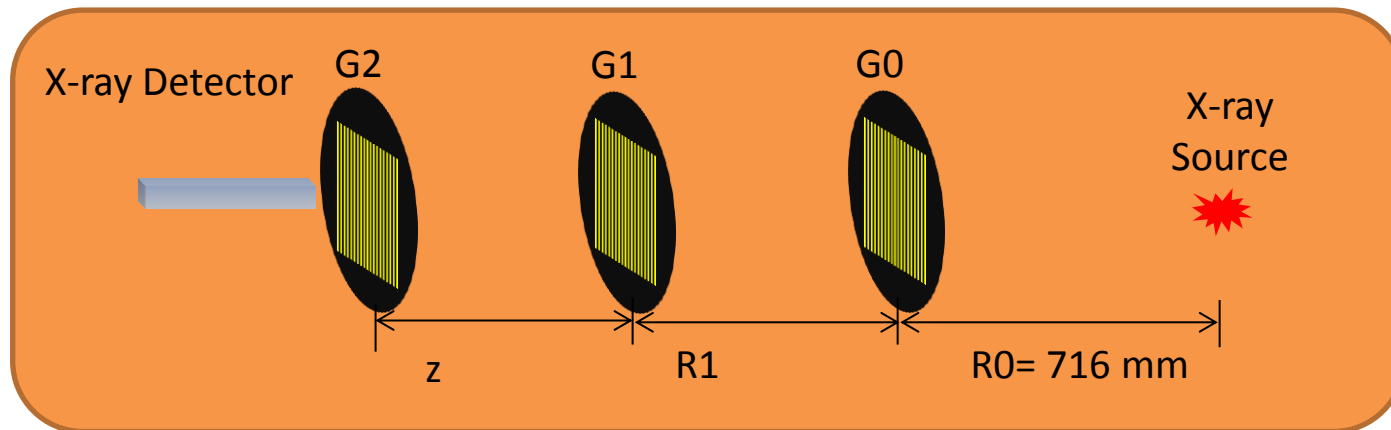
# Overview of this report

1. Measurement of the Moiré fringe visibility using the replacement phase grating for a design energy 30 keV and comparison with the old phase grating.
2. Measurement of the Moiré fringe visibility using the replacement grating when the design energy was changed to 25 keV
  - ☐ Comparison with simulation
3. Conclusions and Recommendation

# Experiment Parameters

<b>X-ray Source</b>	Hamamatsu Photonics Micro-focus Source (Large focus mode) Source size: 300 $\mu\text{m}$ Tube Voltage: 50 kV Tube Current: 300 $\mu\text{A}$
<b>X-ray Detector</b>	Energy-resolving Detector: AMPTEK CdTe diode Pinhole: 1mm, Pinhole thickness: 1mm W Area Detector: 40 $\mu\text{m}$ GOS scintillator connected to CCD Camera via fiber coupling (Spectral Instruments)

## X-ray Talbot-Lau Interferometer Set-up

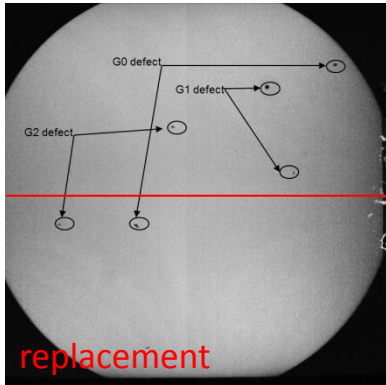
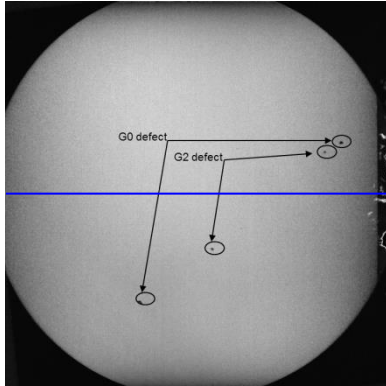


Moiré fringe visibility via fringe scanning. G2 was moved across one period  $d_2$  in steps of  $d_2/5$ . Detector was located at the center of G2.

# Results: Moiré Fringe Visibility

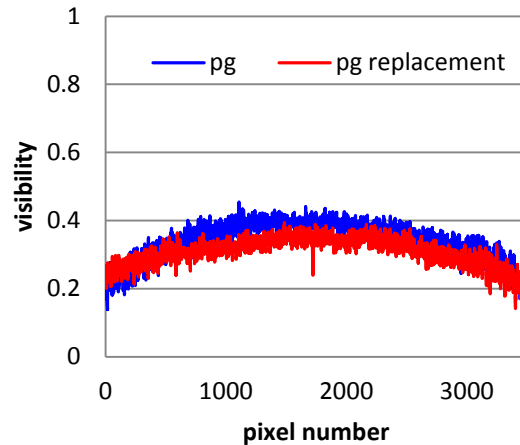
## 1. A Comparison between old and replacement grating

5 step fringe scan:  
1 minute/ step

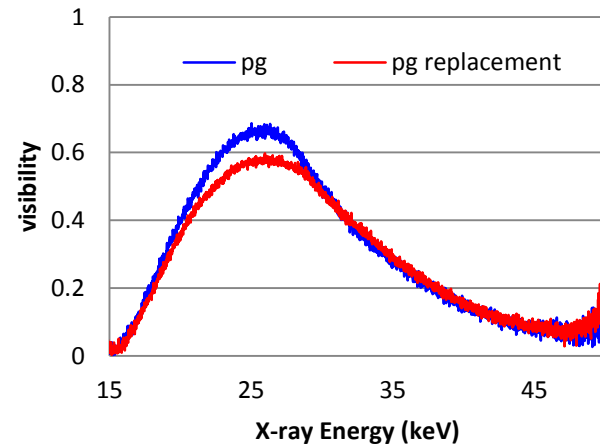


Gray scale: [0, 0.5]

### Visibility line profile



### Energy-resolved Visibility



The energy-resolved visibility measurement shows that the maximum visibility is at 26 keV for both phase gratings.

# Results: Moiré fringe Visibility

## 2. When the design energy was changed to 25keV

The position of the maximum visibility were:

26 keV for design energy 30 keV

24 keV for design energy 25 keV

This shift is confirmed by simulation.

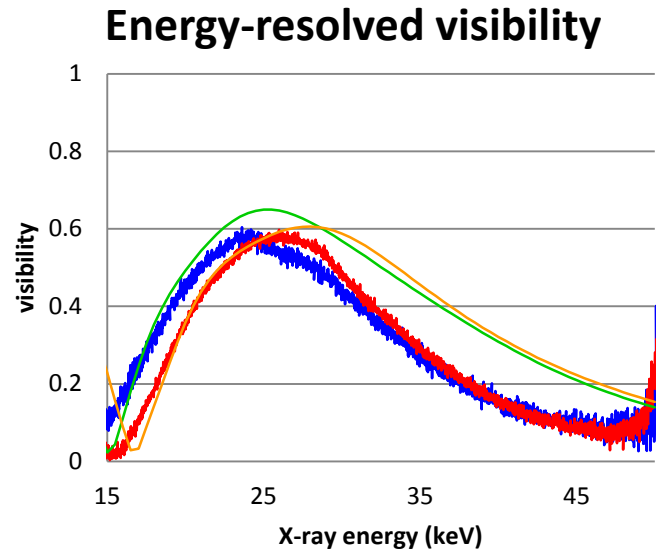
(G1 was assumed to have a  $\pi/2$  shift for 25 keV.)

27 keV for design energy 30 keV

25 keV for design energy 25 keV

The measured visibility at higher energies was lower due to the bridge structures in G2.

The Talbot- Lau interferometer is recommended for operation at an optimum energy of 25 keV.



- exp\_25keV
- exp\_30keV
- sim(h1:25keV)\_25keV
- sim(h1:25keV)\_30keV



## Conclusion and Recommendation

The position of the maximum visibility for the replacement grating was similar to that of the old phase grating.

The Talbot- Lau interferometer using this phase grating is recommended for operation at a design energy of 25 keV.